#### Waters<sup>™</sup>

#### GC/MS/MS Determination of Semivolatiles Using Nitrogen Carrier, Reagent and CID Gas

#### Douglas Stevens Stuart Oehrle, Frank Dorman

Waters Corporation

TIONAL ENVIRONMENTAL MONITORING CONFERENCE

## Hurdles and Highlights for Helium Carrier Gas

- Non-renewable
- Petroleum production by-product
- Supply instability
- Pricing instability

# Will I be able to deliver results on time?

#### Inertness

- Chromatographic resolving power
- Compatibility with MS vacuum
- Compatibility with MS ionization
- Broad applications/publications



#### **Alternatives to Helium**

- Nitrogen
- Local generation possible
- Inertness
- Slower optimum linear velocity
- Requires column scaling
- Adverse effects on sensitivity for EI
- How does N<sub>2</sub> effect GC-APCI?

#### Hydrogen

- Local generation possible
- Undesirable reactivity
- Higher optimum linear velocity
- Requires column scaling
- Adverse effects on sensitivity for EI
- Not supported for GC-APCI

#### GC-APCI MS: Gas Chromatography Atmospheric Pressure Chemical Ionization Mass Spectrometry





#### Multiple Reaction Monitoring: MRM (aka SRM)



- MS1 filters precursor ions
- Gas filled cell with fragmenting voltage applied
- Ions undergo collision induced dissociation (CID)
- MS2 passes only specific product ions

# Why MS/MS?

- Higher confidence
  - Decrease/eliminate false positives/negatives
- Ease of integration
  - Easier to automate
  - Less manual reprocessing
- Time Savings
  - -Allows faster run times
  - -Reduce/eliminate sample clean up steps
  - Reduced/eliminated chemical noise
  - Increases accuracy
  - Improves precision
  - Improves dynamic range



# **Specificity & Sensitivity**

# PAHs: N<sub>2</sub> v He, Without Column Scaling

- N<sub>2</sub> ~10% longer runtime
- He v. N<sub>2</sub> functionally equivalent separation
- Rxi-35Sil MS 30m x .25 x.25
  - No commercially available scaled column



<u>Nitrogen Carrier Gas White Paper, 2023</u>

## Translating Methods from He to N<sub>2</sub> Carrier Gas

- Define gas type
- Scale column dimensions
   Keep phase ratio constant
- Outlet Pressure for APGC (Atm) or EI (Vacuum)

Link to EZGC Method Translator, (Restek)

| Carrier Gas  | 0                        | Original      |                       |   | Translation              |              |                       |     |
|--|--------------------------|---------------|-----------------------|---|--------------------------|--------------|-----------------------|-----|
|  | н                        | elium         | ~                     |   | Nitroge                  | en 🔨         | 2                     |     |
| Column   |                          |               |                       |   |                          |              |                       |     |
| Length   |                          |               | 30.00                 |   |                          | 20.0         | <b>0</b> m            |     |
| Inner Diameter   |                          |               | 0.25                  |   |                          | 0.1          | . <b>5</b> mm         |     |
| Film Thickness   |                          |               | 0.25                  |   |                          | 0.1          | <b>5</b> µm           |     |
| Phase Ratio  |                          |               | 250                   |   |                          | 25           | 0                     |     |
| Control Parameters   |                          |               |                       |   |                          |              |                       |     |
| Column Flow  | -                        | •             | 1.40                  |   | ⇒                        | 0.3          | 8 mL/                 | min |
| Average Velocity   |                          |               | 42.74                 |   |                          | 22.4         | 0 cm/                 | sec |
| Holdup Time  |                          |               | 1.17                  |   |                          | 1.4          | 9 min                 |     |
| InletPressure 🏾 psi 🗸  | <ul> <li>I</li> </ul>    |               | 11.42                 |   |                          | 17.9         | 3 psi                 |     |
| Outlet Pressure (abs)  | Г                        | _             | 0.00                  |   |                          | 14.7         | <b>0</b> psi          |     |
|  |                          | Atm           | Vacuum                |   | Atm                      | Vacuu        | m                     |     |
| Oven Program   |                          |               |                       |   |                          |              |                       |     |
| <ul> <li>○ Isothermal</li> <li>● Ramps</li> </ul>              | Ramp<br>Rate<br>(°C/min) | Temp<br>(°C)  | Hold<br>Time<br>(min) | 1 | Ramp<br>Rate<br>(°C/min) | Temp<br>(°C) | Hold<br>Time<br>(min) |     |
| Ramps (1-4)  |                          | 40            | 1                     |   |                          | 40           | 1.35                  |     |
| 1  | 8.5                      | 330           | 1                     |   | 7.3                      | 330          | 1.15                  |     |
| Control Method   |                          |               |                       |   |                          |              |                       |     |
|  |                          | Constant Flow |                       |   |                          | ~            |                       |     |
| <b>Results</b> Solve for Efficiency O Speed Translate O Custom |                          |               |                       |   |                          |              |                       |     |

#### OCPs: N<sub>2</sub> v He, Scaled Column

 N<sub>2</sub> 40m x .18 x .18 Rxi-5Sil MS

 He 60m x .25 x .25 Rxi-5Sil MS

- 50 peaks (39/11)
- +/- 1.1s average
- He at 1.5 mL/min

N<sub>2</sub> at 0.45 mL/min



Helium

#### Nitrogen

#### Phthalates: N<sub>2</sub> v He, Scaled Column



Rxi-5Sil MS **30 m** x 0.25 mm x 0.25  $\mu$ m for **He** and **20 m** x 0.15 mm x 0.15  $\mu$ m for N<sub>2</sub>

Average r<sup>2</sup> 0.996 for 16 of 17 analytes. Method includes 11 IS/Surr.

#### Multi-Class Semivolatiles (SVOCs)

- Single class SVOC analyses successfully translated to N<sub>2</sub> carrier GC-APCI
- Multi-class SVOC methods present additional challenges
  - Wider range of ionization characteristics
  - Different, specific requirements for long term stability assessment
- With the change to N<sub>2</sub> carrier, evaluation of N<sub>2</sub> collision gas in place of Ar was performed



#### **GC/MS** Conditions

| MS             | Xevo <sup>™</sup> TQ-Absolute  | GC           | Agilent 8890                          |
|----------------|--------------------------------|--------------|---------------------------------------|
| Source Type    | APGC <sup>™</sup> , dry source | Column       | Rxi <sup>®</sup> -SVOCms 20m x 0.15 x |
| Source Temp    | 150°C                          |              | 0.15                                  |
| Transfer Line  | 320°C                          | Outlet       | Atm                                   |
| Temp           |                                | Injection    | SSL, 310°C, Split 10:1, 4 mm pkd      |
| Corona Current | 2.0 μΑ                         |              | liner                                 |
| Auxiliary Gas  | 200 L/hr                       | Carrier Gas  | N <sub>2</sub> , 0.25 mL/min          |
| Cone Gas       | 270 L/hr                       | Temp Program | 40°C 1min, to 120°C at 15°C/min,      |
| Make Up Gas    | 350 mL/min                     |              | to 335°C at 30°C/min hold 7 min.      |
| CID Gas        | N <sub>2</sub> , 0.4 mL/min    |              | 20.5min run time                      |

### Translating From Ar CID Gas to N<sub>2</sub>

Dry source APGC method developed on TQ 2 and transferred to TQ 1

- TQ 2, N<sub>2</sub> carrier gas and N<sub>2</sub> CID gas
  TQ 1, He carrier gas and Ar CID gas
- Identical MRM Transitions

#### TQ 2 N<sub>2</sub> CEs modified for Ar on TQ 1

- Based on guidance in graph



### Estimated v. Optimized, N<sub>2</sub> CID to Ar CID Gas



#### **Comparison Between Different Configurations**



#### **Comparison Between Different Configurations**



#### **Comparison Between Different Configurations**





![](_page_18_Figure_1.jpeg)

![](_page_19_Figure_1.jpeg)

![](_page_20_Figure_1.jpeg)

## All N2 System, TQ2 v. He/Ar System TQ1

- Coefficient of determination > 0.992 v. 0.994
- %RSD IStds <10% v < 7%</p>
- 65 of 67 analytes gave same LOQ on both

![](_page_21_Figure_4.jpeg)

#### Conclusions

- GC-APCI enables translation of SVOC methods to N<sub>2</sub> carrier gas without loss of separation or sensitivity
- N<sub>2</sub> CID gas, in place of Ar, allows a GC/MS/MS system to be operated using a single gas supply
- Dry source (charge exchange) ionization mode demonstrated compatibility with multi-class SVOCs
- However...
- N<sub>2</sub> carrier gas not allowed for EPA SVOC methods (8270, 525, 1625)
- Ability to meet long term stability requirements CCV of some methods requires further evaluation

#### Acknowledgements

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- Gordon Fujimoto, Sarah Dowd, Lindsay Hatch Waters Corporation

![](_page_23_Picture_4.jpeg)

![](_page_23_Picture_5.jpeg)

![](_page_23_Picture_6.jpeg)

#### Thank You for Your Attention. Questions?

![](_page_24_Picture_1.jpeg)

Douglas Stevens Principal Scientist doug\_stevens@waters.com